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(54) **INTEGRATED ASSEMBLIES**

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G11C 11/4091 (2006.01)
G11C 11/4094 (2006.01)
G11C 11/4097 (2006.01)

(52) **U.S. Cl.**

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(58) **Field of Classification Search**

CPC G11C 11/4091; G11C 11/4074
See application file for complete search history.

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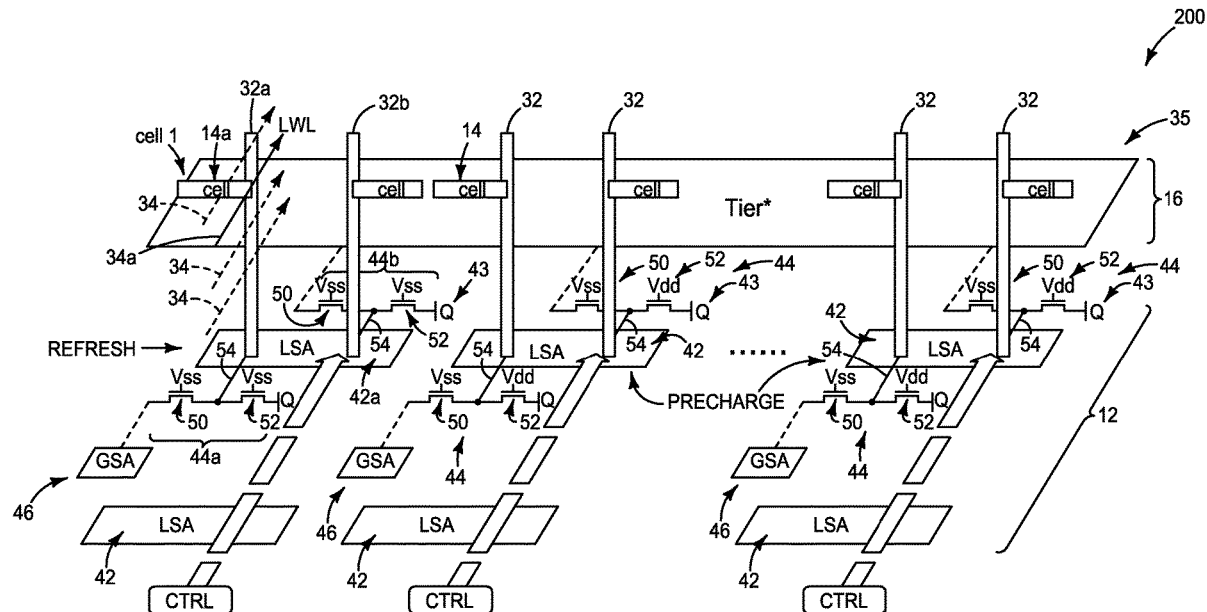
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(57) **ABSTRACT**

Some embodiments include an integrated assembly having a memory array over a base. First sense-amplifier-circuitry is associated with the base and includes sense amplifiers directly under the memory array. Vertically-extending digit lines are associated with the memory array and are coupled with the first sense-amplifier-circuitry. Second sense-amplifier-circuitry is associated with the base and is offset from the first sense-amplifier-circuitry. Control circuitry is configured to selectively couple the digit lines to either a voltage supply terminal or to the second sense-amplifier-circuitry.

27 Claims, 7 Drawing Sheets



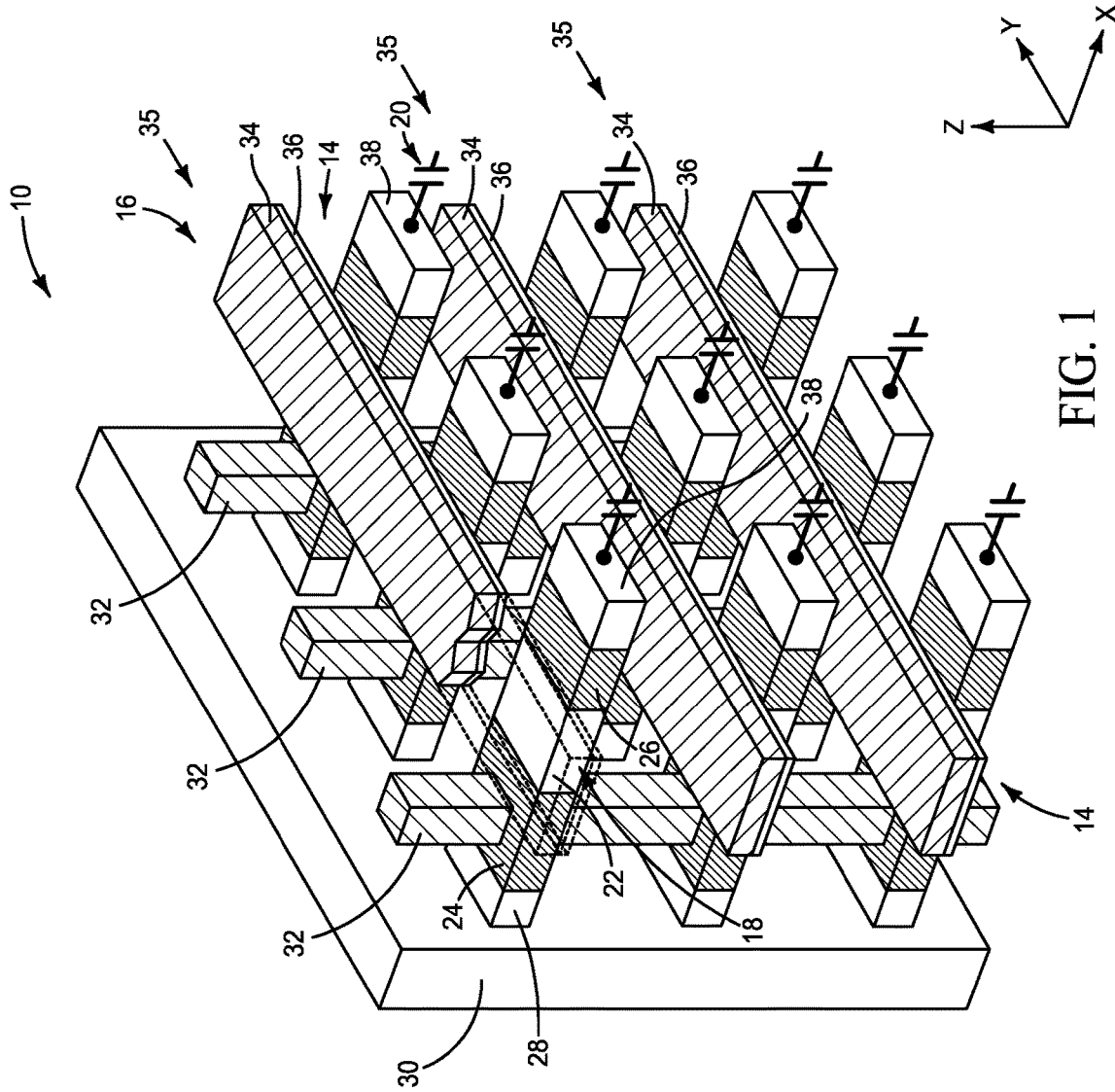


FIG. 1
PRIOR ART

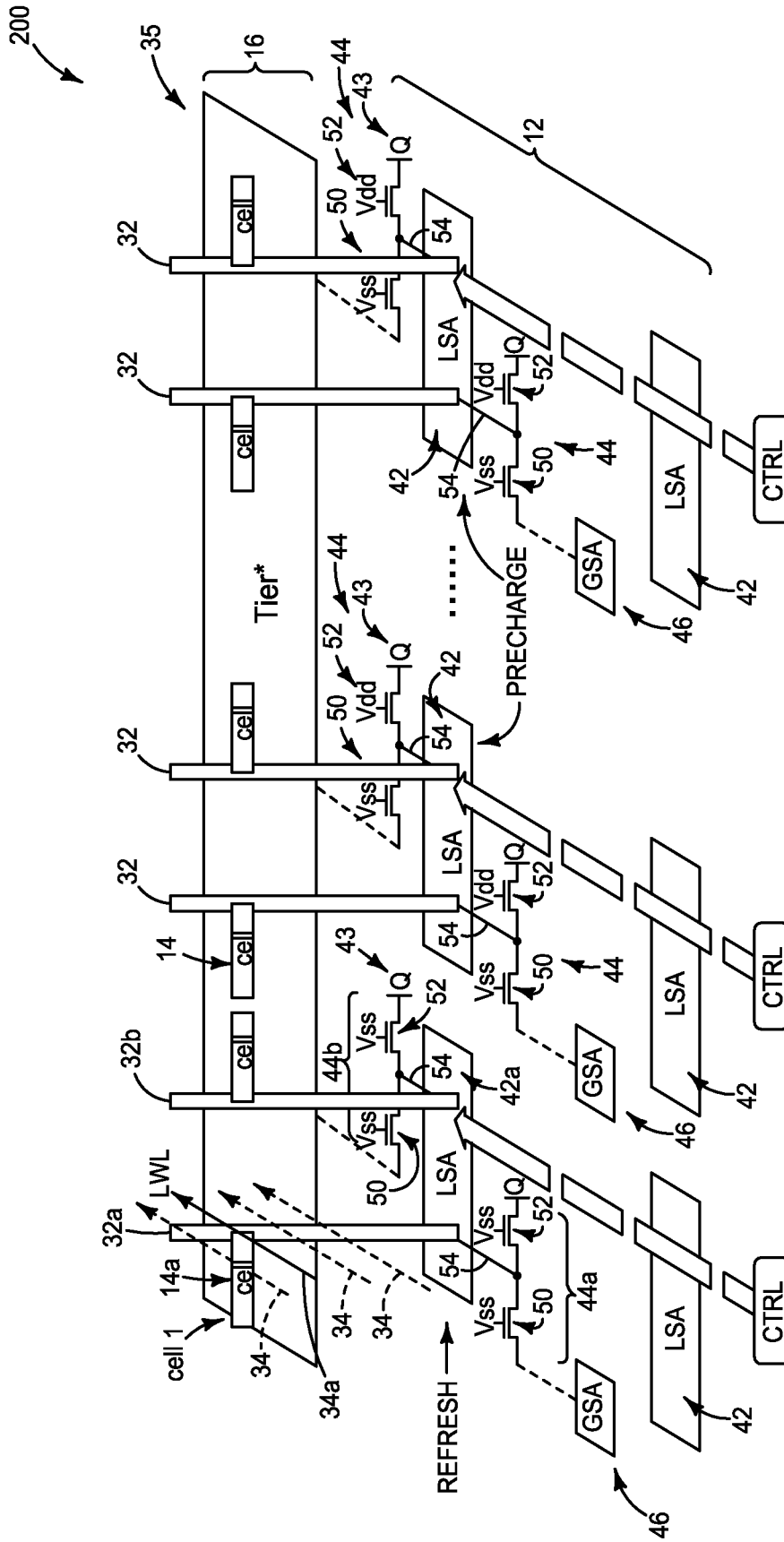


FIG. 3

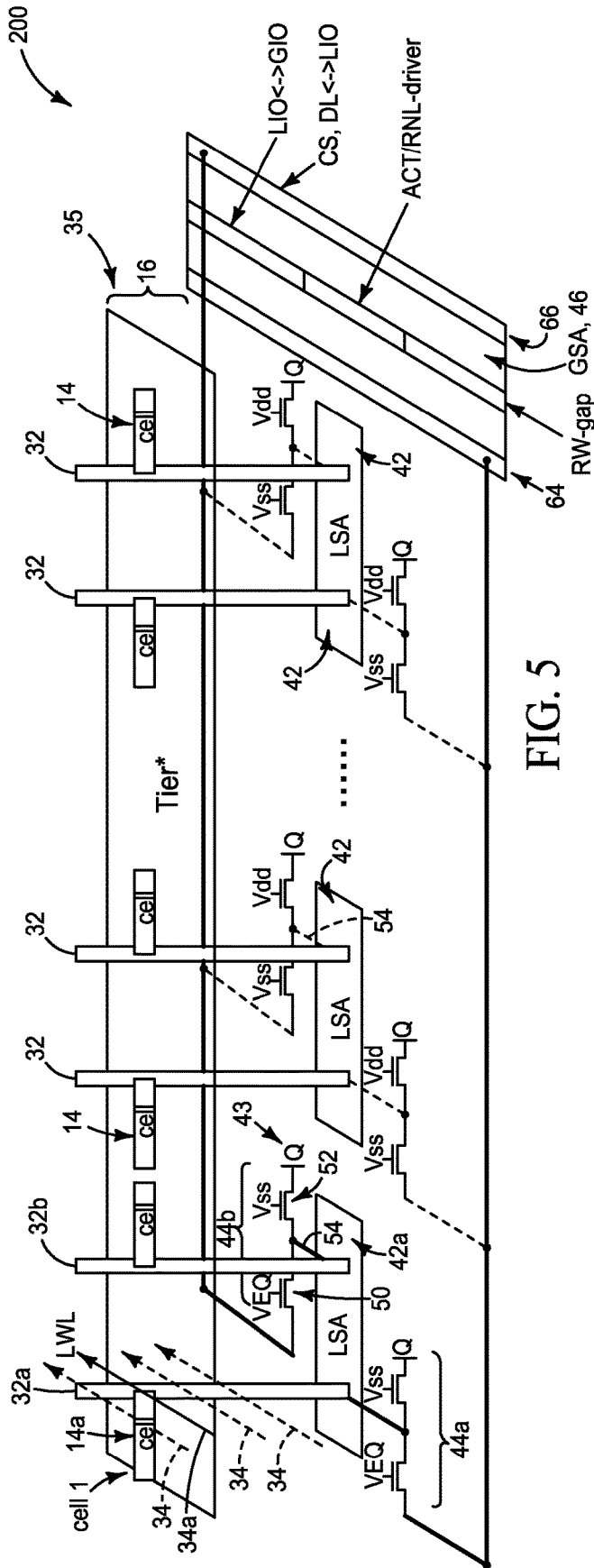


FIG. 5

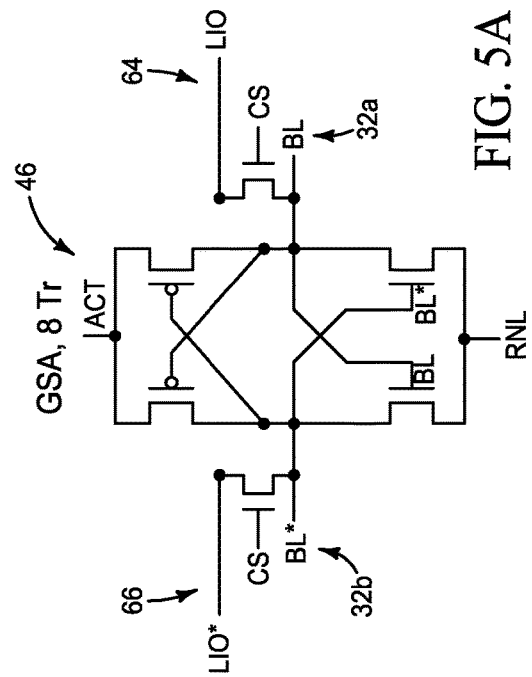


FIG. 5A

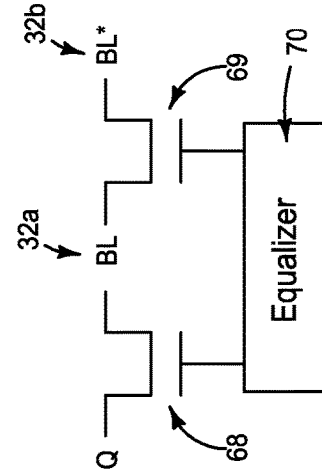


FIG. 5A-1

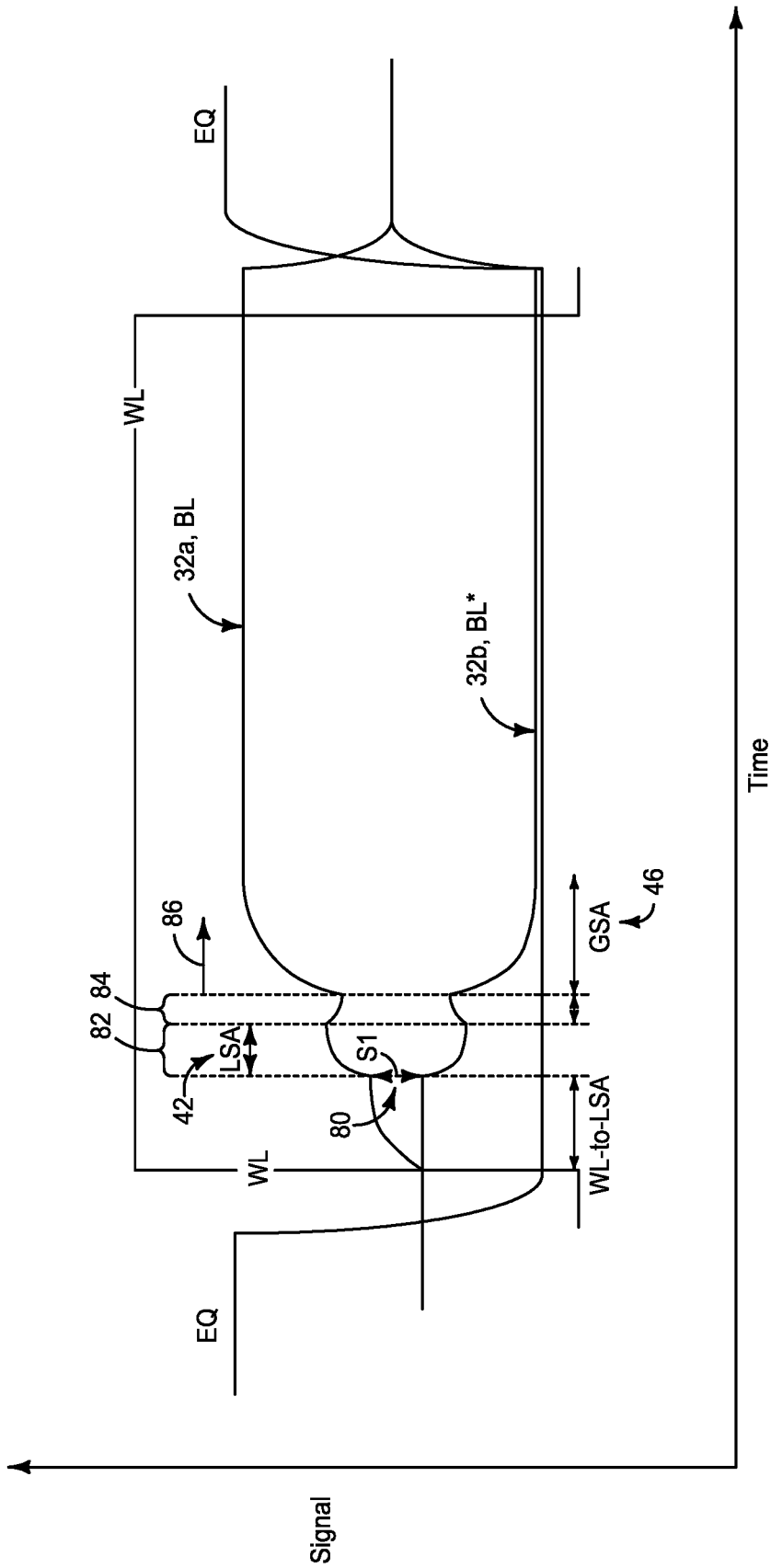


FIG. 6

INTEGRATED ASSEMBLIES

RELATED PATENT DATA

This patent is a divisional of and claims priority to U.S. patent application Ser. No. 17/146,223, filed Jan. 11, 2021, the disclosures of which are incorporated herein by reference.

TECHNICAL FIELD

Integrated memory (e.g., DRAM).

BACKGROUND

Memory is utilized in modern computing architectures for storing data. One type of memory is Dynamic Random-Access Memory (DRAM). DRAM may provide advantages of structural simplicity, low cost and high speed in comparison to alternative types of memory.

DRAM may utilize memory cells which have one capacitor in combination with one transistor (so-called 1T-1C memory cells), with the capacitor being coupled with a source/drain region of the transistor

A region of an example prior art DRAM configuration **10** is shown in FIG. 1. The configuration **10** includes memory cells **14** (only some of which are labeled) arranged in a three-dimensional memory array **16**. An x, y, z coordinate system is provided adjacent to the region of the assembly **10** to assist in describing relative directions of various structures.

Each of the memory cells comprises an access device **18** (only one of which is labeled) coupled with a capacitor **20** (only one of which is labeled).

The access devices **18** correspond to horizontally-extending transistors, with each of the transistors comprising a channel region **22** between a pair of source/drain regions **24** and **26**.

The channel regions and source/drain regions may be formed within semiconductor material **28**. The semiconductor material **28** may comprise any suitable composition(s), and in some embodiments may comprise, consist essentially of, or consist of one or more of silicon, germanium, III/V semiconductor material (e.g., gallium phosphide), semiconductor oxide, etc.; with the term III/V semiconductor material referring to semiconductor materials comprising elements selected from groups III and V of the periodic table (with groups III and V being old nomenclature, and now being referred to as groups 13 and 15).

The source/drain regions **24** and **26** may correspond to heavily-doped regions formed within the semiconductor material **28**.

In the illustrated embodiment, the semiconductor material **28** extends to a conductive plate **30**. The conductive plate **30** may be utilized to drain excess carriers (e.g., holes) from body regions (channel regions) of the transistors **18** in some operational states.

Vertically-extending digit lines (bitlines, sense lines) **32** are along columns of the memory array **16**, and are coupled with the source/drain regions **24**.

Horizontally-extending wordlines (access lines) **34** extend along rows of the memory array **16** and are operatively proximate to the channel regions **22**.

The wordlines **34** extend along an illustrated y-axis direction, and the digit lines **32** extend along an illustrated z-axis direction. The vertically-extending digit lines **32** may be orthogonal to the wordlines **34**, or at least substantially

orthogonal to such wordlines (with the term “substantially orthogonal” meaning orthogonal to within reasonable tolerances of fabrication and measurement). In some embodiments, the digit lines **32** may extend along a direction which is within about 10° of being orthogonal to the wordlines **34**.

The wordlines **34** may be considered to comprise gating regions operatively adjacent to the channel regions **22** of the transistors **18** so that the source/drain regions **24** and **26** of the individual transistors **18** are gatedly coupled to one another. When the term “gated coupling” is utilized herein, such may refer to the controlled coupling/decoupling of the source/drain regions **24** and **26** from one another that may be induced by electrical activation/deactivation the wordlines **34**.

The gating regions along the wordlines **34** are spaced from the channel regions **22** by gate dielectric material **36**. The gate dielectric material may comprise any suitable composition(s), and in some embodiments may comprise, consist essentially of, or consist of silicon dioxide.

The wordlines **34** may extend to wordline-driver-circuitry (e.g., sub-wordline-driver units (SWD units)) outside of the illustrated region of the assembly **10**. Staircase regions may be laterally adjacent to the memory array **16**, and may be utilized for coupling individual wordlines with specific SWD units.

The memory cells **14** may be considered to be arranged within vertically-stacked tiers (levels) **35**.

Conductive nodes **38** (only a couple of which are labeled) are adjacent to the source/drain regions **26**, and couple such source/drain regions with the storage elements **20**. In some embodiments, the conductive nodes **38** may be considered to be part of the storage elements **20**.

In operation, the wordlines **34** may be utilized for selectively coupling a capacitor **20** with a digit line **32** during a READ/WRITE operation associated with a memory cell **14**. Each of the memory cells **14** may be considered to be uniquely addressed utilizing one of the digit lines **32** in combination with one of the wordlines **34**.

The digit lines may be coupled with sensing circuitry (e.g., sense-amplifier-circuitry). The sensing circuitry may be utilized for ascertaining the memory states of memory cells during READ operations, and may be utilized for assisting in the programming of memory cells during WRITE operations.

It is desired to develop sensing circuitry which may be highly-integrated together with the memory array **16** in an integrated assembly.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a diagrammatic three-dimensional view of a region of a prior art integrated assembly having a memory array which extends across multiple vertically-displaced tiers.

FIG. 2 is a diagrammatic cross-sectional side view of a region of an integrated assembly comprising an example arrangement of memory cells, digit lines and sense-amplifier-circuitries.

FIG. 3 is a diagrammatic view of an example arrangement of memory, sense-amplifier-circuitry and control circuitry at an example operational stage.

FIG. 3A is a diagrammatic schematic view of an example layout of an example sense amplifier configuration.

FIG. 3B is a diagrammatic schematic view of an example Mux configuration.

FIG. 3B-1 is a diagrammatic schematic view of an example control circuit which may be utilized with the Mux configuration of FIG. 3B.

FIG. 4 is a diagrammatic view of an example arrangement of memory, sense-amplifier-circuitry and control circuitry at an example operational stage.

FIG. 4A is a diagrammatic schematic view of an example layout of an example sense amplifier configuration.

FIG. 4A-1 is a diagrammatic schematic view of a region of an example equilibration circuit which may be utilized with the sense amplifier configuration of FIG. 4A.

FIG. 5 is a diagrammatic view of an example arrangement of memory, sense-amplifier-circuitry and control circuitry at an example operational stage.

FIG. 5A is a diagrammatic schematic view of an example layout of an example sense amplifier configuration.

FIG. 5A-1 is a diagrammatic schematic view of a region of an example equilibration circuit which may be utilized with the sense amplifier configuration of FIG. 5A.

FIG. 6 is a graphical view of the timing and relative signal strength associated various structures of the memory arrangement of FIG. 5 during example operational stages.

DETAILED DESCRIPTION OF THE ILLUSTRATED EMBODIMENTS

Some embodiments include integrated assemblies having at least two different types of sense-amplifier-circuitries. The two different types may include first sense-amplifier-circuitry and second sense-amplifier-circuitry. The first sense-amplifier-circuitry (which may also be referred to as local sense-amplifier-circuitry) includes sense amplifiers directly under vertically-extending digit lines, and is utilized for PRECHARGE operations, and possibly also for providing signal boosting during READ/WRITE operations. The second sense-amplifier-circuitry (which may also be referred to as global sense-amplifier-circuitry) is utilized for the READ/WRITE operations. Example embodiments are described with reference to FIGS. 2-6.

FIGS. 3-6 describe specific example operations that may be utilized relative to configurations having local sense-amplifier-circuitry and global sense-amplifier-circuitry. Before describing the specific operations, FIG. 2 will be used to generally describe an example orientation of the local sense-amplifier-circuitry and global sense-amplifier-circuitry relative to an example memory array.

FIG. 2 shows a region of an integrated assembly 200 which comprises a memory array 16 analogous to that described above with reference to FIG. 1. The memory array includes a plurality of vertically-extending digit lines 32, and a plurality of horizontally-extending wordlines 34. The wordlines 34 extend in and out of the page relative to the cross-sectional view of FIG. 2. Insulative materials are not specifically illustrated in FIG. 2, but rather locations of the insulative materials are diagrammatically indicated with spaces. Accordingly, the gate dielectric material 36 of FIG. 1 is diagrammatically indicated in FIG. 2 by spaces between the wordlines 34 and the underlying memory cells 14.

The memory cells 14 (only one of which is labeled) extend horizontally along an illustrated x-axis, with the memory cells comprising access devices 18 (only some of which are labeled) and capacitors 20. In the shown embodiment, laterally-adjacent capacitors share a plate electrode 40.

The memory array 16 may be considered to comprise a three-dimensional arrangement of the memory cells 14, with such arrangement having rows extending in and out of the

page relative to the cross-section of FIG. 2 (i.e., extending along the illustrated y-axis of FIG. 1), and having columns extending along the illustrated z-axis. Accordingly, the wordlines 34 may be considered to be associated with the rows of the memory array, and the digit lines (bitlines) 32 may be considered to be associated with the columns of the memory array.

The illustrated region of the memory array 16 comprises four of the vertically-stacked tiers 35 of the memory cells 14. It is to be understood that the memory array 16 may comprise any suitable number of the tiers 35. In some embodiments, the memory array 16 may comprise 4 of the vertically-stacked tiers (as shown), 8 of the vertically-stacked tiers, 16 of the vertically-stacked tiers, 32 of the vertically-stacked tiers, 64 of the vertically-stacked tiers, etc.

The memory array 16 may be considered to be supported by an underlying base 12. The base 12 may comprise semiconductor material; and may, for example, comprise, consist essentially of, or consist of monocrystalline silicon. The base 12 may be referred to as a semiconductor substrate. The term "semiconductor substrate" means any construction comprising semiconductive material, including, but not limited to, bulk semiconductive materials such as a semiconductive wafer (either alone or in assemblies comprising other materials), and semiconductive material layers (either alone or in assemblies comprising other materials). The term "substrate" refers to any supporting structure, including, but not limited to, the semiconductor substrates described above. In some applications, the base 12 may correspond to a semiconductor substrate containing one or more materials associated with integrated circuit fabrication. Such materials may include, for example, one or more of refractory metal materials, barrier materials, diffusion materials, insulator materials, etc.

First sense-amplifier-circuitry 42 is associated with the base 12, and is subdivided into a plurality of local sense amplifiers (LSAs). Lateral boundaries of the individual LSAs are diagrammatically illustrated with dashed lines. The boundaries are shown to be elliptical, but may comprise any suitable shapes, including, for example, polygonal shapes, circular shapes, etc. The individual LSAs may comprise any suitable dimensions.

Each LSA comprises NMOS and PMOS transistors, as described in more detail below relative to FIG. 3A. The NMOS and PMOS transistors may be within CMOS supported by the base 12. Such CMOS may include regions which extend into the base 12 and/or may include regions over the base 12.

The LSA regions 42 are directly under the memory array 16, and in the shown embodiment each LSA region is directly under a pair of the digit lines 32. For instance one of the LSA regions is labeled 42a, and is shown to be directly under a pair of digit lines labeled 32a and 32b. The digit lines 32a and 32b are shown to be electrically coupled with the LSA region 42a. One of the digit lines 32a and 32b may be a "true" digit line (BL) and the other may be a complementary digit line (BL*). The true and complementary digit lines 32a and 32b may be coupled to one another through the LSA region 42a during some operations (e.g., PRECHARGE operations, REFRESH operations, etc.).

In some operations, the complementary digit lines may be comparatively coupled to one another through sense-amplifier-circuitry. For purposes of understanding this disclosure and the claims that follow, a first digit-line is "comparatively coupled" with a second digit-line through sense-amplifier-circuitry if the sense-amplifier-circuitry is configured to

compare electrical properties (e.g., voltage) of the first and second digit-lines with one another. It is noted that the terms “true” and “complementary” are arbitrary as utilized to label digit lines, and are simply used to differentiate the digit-lines which are compared to one another through sense-amplifier-circuitry.

The digit lines **32** are shown to be coupled with control circuitry **44**. The control circuitry may be associated with the base **12**. The control circuitry **44** is configured to electrically connect the digit lines with either a voltage supply terminal **43** (which provides voltage Q), or with a second sense-amplifier-circuitry **46**. The second sense-amplifier-circuitry is shown to correspond to a global sense amplifier (GSA). The GSA unit (also referred to herein as a GSA region, or simply as a GSA) **46** may be in a location which is offset (e.g., laterally offset) relative to the LSA regions, and which is not directly under the memory array **16**. An example GSA unit is described in more detail below with reference to FIG. 4.

Referring still to FIG. 2, the control circuitry **44** is coupled with a control unit **48** which is configured for controlling access of the digit lines to the voltage supply terminals **43** and the GSAs **46**. The control unit **48** may be provided in any suitable location. For instance, the control unit **48** may be associated with the base **12**, and may be laterally offset from the control circuitries **44** and the memory array **16**.

In practice, the local sense amplifiers **42** may be relatively simple structures utilized for PRECHARGE operations, for REFRESH operations, and possibly also for providing signal boost during READ/WRITE operations. The global sense amplifier **46** may be a more complex structure utilized for READ/WRITE operations, and not for PRECHARGE operations and REFRESH operations.

An example PRECHARGE operation relative to the digit lines **32** may be described as follows. All of the wordlines **34** may be turned OFF, and the control unit **48** may be utilized to switch the control circuitry **44** to the voltage supply terminals **43**. Such couples the digit lines **32** with the voltage Q of the voltage supply terminals, and thus charges the digit lines to the voltage Q. The voltage Q may be any suitable voltage, and in some embodiments may be about VCC/2.

An example REFRESH operation relative to the digit lines **32** may be described relative to the digit line **32a**. After the PRECHARGE operation, the digit lines **32a** and **32b** will both be at the voltage Q. Subsequently, one of the wordlines **34** (for instance the wordline labeled **34a**) may be activated, and such places the contents from the memory cell **14a** onto the digit line **32a**. The LSA **42a** may then be utilized to comparatively couple the digit lines **32a** and **32b**, which results in the contents of the memory cell **14a** being restored to a full charge/discharge level (i.e., a full rail level). Notably, the REFRESH operation may be conducted simultaneously within all of the digit lines associated with an activated wordline, and thus may simultaneously refresh an entire row of memory cells.

An example READ operation relative to the digit lines **32** may be described relative to the digit line **32a**. After the PRECHARGE operation, the wordline **34a** may be activated to transfer the contents from the cell **14a** onto the digit line **32a**, and the control unit **48** may be utilized to switch the control circuitries **44a** and **44b** so that the digit lines **32a** and **32b** are comparatively coupled to one another through the GSA **46** to ascertain the memory state of the cell **14a**.

A WRITE operation is similar to the READ operation, except that data is transferred to the memory cell rather than being read from the memory cell.

The READ operation described above primarily utilized the GSA **46** to ascertain the contents of the memory cell **14a**. In other embodiments, the LSA **42a** may be initially used to perform an initial pre-sensing (a “soft” sensing) of the memory state of the cell **14a**, and to boost the signal from the digit line **32a** prior to utilization of the GSA **46**. FIGS. 5 and 6 describe the utilization of the LSAs **42** in pre-sensing operations in more detail.

Referring to FIG. 3, such shows a region of the integrated assembly **200** utilized for example PRECHARGE/REFRESH operations. The assembly comprises the digit lines **32** associated with the LSA regions **42**. An example memory tier **35** is illustrated as part of a memory array **16**, and wordlines **34** are shown to extend along the tiers of the memory **16**, with one of the wordlines (**34a**) being activated during the REFRESH operation, and being readily distinguishable from the other wordlines as it is a solid line labeled LWL. The wordline LWL and digit line **32a** together address a memory cell **14a** (cell 1).

Individual units of the control circuitry **44** are each shown to comprise a routing structure **54**, and two switches (transistors) **50** and **52**, with two of the units being labeled **44a** and **44b**. The transistors **50** and **52** are adjacent to one another, and may be referred to as first and second transistors, respectively.

FIG. 3B shows one of the control circuitries **44** in more detail. The first transistors **50** have first gates **51**, and have first and second source/drain regions **53** and **55**; and the second transistors **52** have second gates **57**, and have third and fourth source/drain regions **59** and **61**. The first gates **51** gatedly couple the first and second source/drain regions **53** and **55** with one another, and the second gates **57** gatedly couple the third and fourth source/drain regions **59** and **61** with one another.

The first transistor gates **51** may comprise a deactivation voltage of about VSS (Vss), and an activation voltage of about VEQ; and the second transistor gates **57** may comprise a deactivation voltage of about VSS and an activation voltage of about VDD (Vdd). The voltage VDD may be about the same as the voltage VCC. The voltage VEQ may be greater than the voltage VDD, and accordingly the first transistor **51** may have a higher threshold voltage than the second transistor **57**. In other embodiments, the first and second transistors **51** and **57** may have substantially the same threshold voltage as one another, and may be activated with substantially the same activation voltage as one another; where the term “substantially the same” means the same to within reasonable tolerances of fabrication and measurement. An advantage of having a higher threshold voltage associated with the transistor **51** is that such may be suitable for transferring high voltage signals from the digit lines **32** to the GSA circuitry **46**. In contrast, the lower threshold voltage transistors **57** may be suitable for the PRECHARGE/REFRESH operations associated the digit lines **32**.

The routing structures **54** are coupled with the second and third source/drain regions **55** and **59**, and extend from the second/third source/drain regions to the digit lines **32**.

The first source/drain regions **53** are coupled with the second sense-amplifier-circuitry **46** (the GSA circuitry), and the fourth source/drain regions **61** are coupled with the voltage supply terminals **43**. The voltage supply terminals **43** are coupled with a voltage source at the voltage level Q (e.g., VCC/2).

The first and second gates **51** and **57** are coupled with the control unit **48**. In some embodiments, the control circuitry **44** may be referred to as Mux (multiplexer) circuitry (or as

Mux components), and the control unit **48** may be referred to as Mux-Driver-circuitry. The Mux-Driver-circuitry **48** is configured to selectively activate/deactivate one or both of the first and second gates **51** and **57** during programming operations (e.g., during PRECHARGE operations, REFRESH operations, READ operations, WRITE operations, etc.). In the illustrated embodiments of FIGS. **2** and **3**, the Mux components **44** are in one-to-one correspondence with the digit lines **32**.

The embodiment of FIG. **3B** refers to the first gate **51** as being associated with a Selector (A), and refers to the second gate **57** as being associated with a Bleeder (B). The terms Selector and Bleeder are utilized to convey example operational aspects of the gates **51** and **57**, with the gate **51** being utilized to “select” the GSA circuitry **46**, and the gate **57** being utilized to “bleed” the voltage level Q into the digit lines **32** during PRECHARGE operations.

FIG. **3B-1** diagrammatically illustrates example control circuitry that may be associated with the Mux-Driver-circuitry **48** and with the LSAs **42**.

FIG. **3A** diagrammatically illustrates an example LSA **42**. The LSA comprises a pair of cross-coupled PMOS transistors (pull-up transistors) **56** and **58**, and comprises a pair of cross-coupled NMOS transistors (pulldown transistors) **60** and **62**. The PMOS transistors **56** and **58** may be considered together as a PSA region **63** (pull-up region), and the NMOS transistors **60** and **62** may be considered together as an NSA region **65** (pulldown region). Signals from a pair of comparatively coupled bitlines (BL and BL*, which correspond to the digit lines **32a** and **32b**, respectively) are shown to be associated with the LSA **42**. One of the signals will be higher than the other. The LSA **42** is configured to drop the lower signal to a full discharge level, and to lift the higher signal to a full charge level. The symbols ACT and RNL refer to voltage levels, as will be understood by person of ordinary skill.

The NMOS and PMOS transistors of the LSA **42** may be within CMOS supported by the base **12**.

The LSA **42** of FIG. **3** is a simple device that utilizes only four transistors (Tr). Such device may be readily incorporated into applications of the type described above with reference to FIGS. **2** and **3** in which the device is provided directly under adjacent digit lines. The LSA devices may be kept relatively small, especially as compared to GSA devices (with example GSA devices being described below).

Referring again to FIG. **3**, the assembly **200** is shown at an operational stage during a REFRESH operation associated with the digit line **32a**. The first and second transistors **50** and **52** within the Mux components **44a** and **44b** are deactivated (i.e., the gate voltages to such transistors is Vss), and accordingly the digit lines **32a** and **32b** are comparatively coupled one another through the LSA **42a**. Notably, the other digit lines are maintained in a PRECHARGE state, and specifically the second transistors **52** associated with such digit lines are activated (i.e., the gate voltages are Vdd) so that the digit lines are coupled with the PRECHARGE voltage Q.

FIG. **4** shows an example READ operation utilizing the GSA **46**. The first transistors **50** of the Mux components **44a** and **44b** are activated (i.e., the gate voltages to such transistors is VEQ), and the second transistors **52** of the Mux components **44a** and **44b** are deactivated (i.e., the gate voltages to such transistors is Vss), and accordingly the digit lines **32a** and **32b** are comparatively coupled through the GSA **46**. The activated wordline **34a** (LWL) and the digit

line **32a** together address the memory cell **14a** (cell **1**), and the content of such cell is accessed during the READ operation of FIG. **4**.

The signals from the digit lines **32a** and **32b** are passed to column-select-circuitry **64** and **66**, and from the column-select-circuitry to the GSA circuitry **46**. FIG. **4A** diagrammatically illustrates an example GSA configuration **46**. The configuration includes local input/output signals (LIO) that pass to the column-select-circuitry **64** and **66**, as will be understood by persons of ordinary skill. The column-select-circuitry **64/66** is utilized for addressing the selected digit lines **32a** and **32b**, with such digit lines being referenced as BL and BL* in FIG. **4A**.

The GSA configuration of FIG. **4A** comprises 12 transistors, and accordingly is much larger than the LSA configurations of FIG. **3A**. The GSA configuration of FIG. **4A** comprises a pair of cross-coupled PMOS transistors (pull-up transistors) **72** and **74**, and comprises a pair of cross-coupled NMOS transistors (pulldown transistors) **76** and **78**. The column-select-circuitry **64/66** comprises a first transistor **71a** laterally offset from a first side **73a** of a region comprising the pull-up and pulldown transistors, and comprises a second transistor **71b** laterally offset from a second side **73b** of the region comprising the pull-up and pulldown transistors, with the second side being in opposing relation to the first side.

In some embodiments, the GSA configuration of FIG. **4A** may have a higher threshold voltage associated therewith than does the LSA configuration of FIG. **3A**. The threshold voltage associated a sense amplifier may be understood to be related to the threshold voltages associated with the transistors (e.g., the PMOS transistors and NMOS transistors) of the sense amplifier. It may be advantageous for the GSA to have a higher threshold voltage than the LSAs as it may be desirable to configure the GSA and LSAs to be suitable for handling (and generating) different load levels (i.e., different levels of signal strengths).

The NMOS and PMOS transistors of the GSA configuration of FIG. **4A** may be within CMOS supported by the base **12**. In some embodiments, the CMOS circuitry of the GSA configuration of FIG. **4A** may be referred to as second CMOS circuitry to distinguish it from the first CMOS circuitry of the LSA configuration of FIG. **3A**.

The embodiment of FIG. **4** shows the GSA **46** to be associated with numerous of the LSAs **42**. The illustrated embodiment shows three of the LSAs **42** to be associated with the GSA **46**, but indicates that there may be more than three of the LSAs associated with the GSA. In some embodiments, there may be at least about 10 of the local sense amplifiers (LSAs **42**) associated a single global sense amplifier (GSA **46**), at least about 100 of the local sense amplifiers associated with the single global sense amplifier, at least about 500 of the local sense amplifiers associated the single global sense amplifier, etc.

The view of FIG. **4** may be considered to illustrate a slice through a three-dimensional configuration comprising the three-dimensional array **16** of the memory cells **14**. There may be a large number of such slices (e.g., at least about 10 of such slices, at least about 50 such slices, at least about 100 of such slices, etc.), and each of the slices may comprise a global sense amplifier **46** associated with a large number of local sense amplifiers. Accordingly, in some embodiments there may be at least about 10 global sense amplifiers, at least about 50 global sense amplifiers, at least about 100 global sense amplifiers, etc., associated a three-dimensional memory array.

The sense amplifier assembly of FIG. 4A may be equilibrated with any suitable equilibration configuration. FIG. 4A-1 shows an example configuration 67 which utilizes a pair of transistors 68 and 69, and a control unit 70 (Equalizer) configured for controlling activation/deactivation of the transistors 68 and 69. Voltage levels Q, R and S are shown at source/drain regions of the transistors. The voltage level Q may be the PRECHARGE level described above, and the levels R and S may be any suitable levels, as will be understood by persons of ordinary skill.

The configuration of FIG. 4 is described as utilizing the GSA 46 for the READ operation. In other embodiments, the GSA 46 may be utilized in combination with an LSA 42 during a READ operation. For instance, FIG. 5 shows the assembly 200 at a process stage similar to that of FIG. 4, but in which the LSA 42a is utilized for the read operation in addition to the GSA 46. The configuration of FIG. 5 is similar to that of FIG. 4, but the boundaries of the LSA regions of FIG. 5 are shown with solid lines and those of FIG. 4 are shown with dashed lines to diagrammatically indicate a difference in usage of the LSA regions. Differences between the embodiment of FIG. 5 and that of FIG. 4 may be further understood with reference to FIGS. 5A and 5A-1. Specifically, FIG. 5A shows that the GSA configuration may now be an eight transistor configuration rather than the 12 transistor configuration of FIG. 4A. FIG. 5A-1 shows that a circuit comparable to the equalizer circuit of FIG. 4A-1 now utilizes signals (voltages) from the bitlines 32a and 32b.

FIG. 6 graphically shows relative signal strength versus time for various structures associated with the assembly 200 of FIG. 5 during a READ operation. At an early stage 80 of the READ operation, the difference in signal strength between the bitlines 32a and 32b is illustrated to be an amount S1. In some embodiments, S1 may be less than or equal to about 200 mV (millivolts). At a subsequent stage 82, the difference in signal strength between the bitlines 32a and 32b is boosted utilizing the LSA circuitry 42. There may be a minor loss in the difference in signal strength between the bitlines 32a and 32b during a stage 84 as the signals of the digit lines are transferred from the LSA circuitry 42 to the GSA circuitry 46, and then a stage 86 is entered whereupon the GSA circuitry 46 is utilized to substantially boost the difference in signal strength between the digit lines 32a and 32b.

The assemblies and structures discussed above may be utilized within integrated circuits (with the term “integrated circuit” meaning an electronic circuit supported by a semiconductor substrate); and may be incorporated into electronic systems. Such electronic systems may be used in, for example, memory modules, device drivers, power modules, communication modems, processor modules, and application-specific modules, and may include multilayer, multi-chip modules. The electronic systems may be any of a broad range of systems, such as, for example, cameras, wireless devices, displays, chip sets, set top boxes, games, lighting, vehicles, clocks, televisions, cell phones, personal computers, automobiles, industrial control systems, aircraft, etc.

Unless specified otherwise, the various materials, substances, compositions, etc. described herein may be formed with any suitable methodologies, either now known or yet to be developed, including, for example, atomic layer deposition (ALD), chemical vapor deposition (CVD), physical vapor deposition (PVD), etc.

The terms “dielectric” and “insulative” may be utilized to describe materials having insulative electrical properties. The terms are considered synonymous in this disclosure. The utilization of the term “dielectric” in some instances,

and the term “insulative” (or “electrically insulative”) in other instances, may be to provide language variation within this disclosure to simplify antecedent basis within the claims that follow, and is not utilized to indicate any significant chemical or electrical differences.

The terms “electrically connected” and “electrically coupled” may both be utilized in this disclosure. The terms are considered synonymous. The utilization of one term in some instances and the other in other instances may be to provide language variation within this disclosure to simplify antecedent basis within the claims that follow.

The particular orientation of the various embodiments in the drawings is for illustrative purposes only, and the embodiments may be rotated relative to the shown orientations in some applications. The descriptions provided herein, and the claims that follow, pertain to any structures that have the described relationships between various features, regardless of whether the structures are in the particular orientation of the drawings, or are rotated relative to such orientation.

The cross-sectional views of the accompanying illustrations only show features within the planes of the cross-sections, and do not show materials behind the planes of the cross-sections, unless indicated otherwise, in order to simplify the drawings.

When a structure is referred to above as being “on”, “adjacent” or “against” another structure, it can be directly on the other structure or intervening structures may also be present. In contrast, when a structure is referred to as being “directly on”, “directly adjacent” or “directly against” another structure, there are no intervening structures present. The terms “directly under”, “directly over”, etc., do not indicate direct physical contact (unless expressly stated otherwise), but instead indicate upright alignment.

Structures (e.g., layers, materials, etc.) may be referred to as “extending vertically” to indicate that the structures generally extend upwardly from an underlying base (e.g., substrate). The vertically-extending structures may extend substantially orthogonally relative to an upper surface of the base, or not.

Some embodiments include an integrated assembly having a memory array over a base. The memory array has a three-dimensional arrangement of memory cells. First sense-amplifier-circuitry is associated with the base and includes sense amplifiers directly under the memory array. Vertically-extending digit lines pass through the arrangement of the memory cells and are coupled with the first sense-amplifier-circuitry. Second sense-amplifier-circuitry is associated with the base and is offset from the first sense-amplifier-circuitry. Control circuitry is configured to selectively couple the digit lines to either a voltage supply terminal or to the second sense-amplifier-circuitry.

Some embodiments include an integrated assembly comprising a memory array over a base. First sense-amplifier-circuitry is associated with the base and comprises sense amplifiers directly under the memory array. Vertically-extending digit lines are associated with the memory array and are coupled with the first sense-amplifier-circuitry. Second sense-amplifier-circuitry is offset from the first sense-amplifier-circuitry. The first sense-amplifier-circuitry is configured to be utilized in PRECHARGE operations. The second sense-amplifier-circuitry is configured to be utilized in READ/WRITE operations but not in the PRECHARGE operations.

Some embodiments include an integrated assembly comprising a memory array over a base. Vertically-extending digit lines are associated with the memory array. Sense amplifiers are under the memory array and are coupled with

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the digit lines. Routing structures are coupled to each of the digit lines and extend to Mux components. The Mux components are in one-to-one correspondence with the digit lines. Each of the Mux components comprises a first transistor and a second transistor. The first transistors have first gates, first source/drain regions and second source/drain regions. The first gates gatedly couple the first and second source/drain regions with one another. The second transistors have second gates, third source/drain regions and fourth source/drain regions. The second gates gatedly couple the third and fourth source/drain regions with one another. The routing structures are coupled with the second and third source/drain regions. The first source/drain regions are coupled with second sense-amplifier-circuitry. The fourth source/drain regions are coupled with a voltage source. The first and second gates are coupled with Mux-Driver-circuitry configured to selectively activate/deactivate the first and second gates.

In compliance with the statute, the subject matter disclosed herein has been described in language more or less specific as to structural and methodical features. It is to be understood, however, that the claims are not limited to the specific features shown and described, since the means herein disclosed comprise example embodiments. The claims are thus to be afforded full scope as literally worded, and to be appropriately interpreted in accordance with the doctrine of equivalents.

We claim:

1. An integrated assembly, comprising:
a memory array over a base;
vertically-extending digit lines associated with the memory array;
sense amplifiers comprising first sense-amplifier-circuitry under the memory array and coupled with the digit lines, circuitry of the first sense-amplifier-circuitry configured to be utilized to provide signal boost during READ/WRITE operations; and
routing structures coupled to each of the digit lines and extending to Mux components; the Mux components being in one-to-one correspondence with the digit lines; each of the Mux components comprising a first transistor and a second transistor; the first transistors having first gates, first source/drain regions and second source/drain regions; the first gates gatedly coupling the first and second source/drain regions with one another; the second transistors having second gates, third source/drain regions and fourth source/drain regions; the second gates gatedly coupling the third and fourth source/drain regions with one another; the routing structures being coupled with the second and third source/drain regions; the first source/drain regions being coupled with second sense-amplifier-circuitry comprising a different type of sense-amplifier-circuitry compared to the first sense-amplifier-circuitry; the fourth source/drain regions being coupled with a voltage source; the first and second gates being coupled with Mux-Driver-circuitry configured to selectively activate/deactivate the first and second gates.
2. The integrated assembly of claim 1 wherein the Mux-Driver-circuitry is associated with the base and is laterally offset from the second sense-amplifier-circuitry.
3. The integrated assembly of claim 1 wherein the first transistors have higher threshold voltages than the second transistors.
4. The integrated assembly of claim 1 wherein the first transistors have substantially the same threshold voltage as the second transistors.

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5. The integrated assembly of claim 1 wherein:
the first sense amplifier-circuitry is in configurations having no more than 4 transistors; and
the second sense amplifier-circuitry is in configurations having at least 8 transistors.
6. The integrated assembly of claim 5 wherein the second sense amplifiers are in configurations having at least 12 transistors.
7. The integrated assembly of claim 1 wherein:
the first sense-amplifier-circuitry comprises a first threshold voltage associated therewith;
the second sense-amplifier-circuitry comprises a second threshold voltage associated therewith; and
the second threshold voltage is greater than the first threshold voltage.
8. The integrated assembly of claim 1 wherein the sense amplifiers are local sense amplifiers, wherein the second sense-amplifier-circuitry comprises global sense amplifiers, and wherein at least 10 of the local sense amplifiers are associated with each of the global sense amplifiers.
9. The integrated assembly of claim 1 wherein the sense amplifiers are local sense amplifiers, wherein the second sense-amplifier-circuitry comprises global sense amplifiers, and wherein at least 100 of the local sense amplifiers are associated with each of the global sense amplifiers.
10. The integrated assembly of claim 1 wherein the sense amplifiers are local sense amplifiers, wherein the second sense-amplifier-circuitry comprises global sense amplifiers, and wherein at least 500 of the local sense amplifiers are associated with each of the global sense amplifiers.
11. The integrated assembly of claim 1 further comprising an equalizer utilized to equilibrate the sense amplifiers.
12. The integrated assembly of claim 11 further comprising a pair of transistors utilized to equilibrate the sense amplifiers.
13. The integrated assembly of claim 12 wherein the equalizer is configured for controlling activation/deactivation of the pair of transistors.
14. The integrated assembly of claim 11 wherein voltages from the digit lines are utilized to equilibrate the sense amplifiers.
15. The integrated assembly of claim 1 wherein the circuitry of the first sense-amplifier-circuitry is configured to be utilized to additionally provide for PRECHARGE operations.
16. The integrated assembly of claim 1 wherein the circuitry of the first sense-amplifier-circuitry is configured to be utilized to additionally provide for REFRESH operations.
17. The integrated assembly of claim 1 wherein circuitry of the second sense-amplifier-circuitry is configured to be utilized to provide only READ/WRITE operations.
18. The integrated assembly of claim 1 wherein the circuitry of the first sense-amplifier-circuitry is configured to be utilized to additionally provide for:
REFRESH operations; and
PRECHARGE operations.
19. An integrated assembly, comprising:
a memory array over a base;
vertically-extending digit lines associated with the memory array;
sense amplifiers under the memory array and coupled with the digit lines, wherein circuitry of at least one sense amplifier is configured to be utilized to provide for REFRESH operations and PRECHARGE operations;
routing structures coupled to each of the digit lines and extending to Mux components; the Mux components

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being in one-to-one correspondence with the digit lines; each of the Mux components comprising a first transistor and a second transistor; the first transistors having first gates, first source/drain regions and second source/drain regions; the first gates gately coupling the first and second source/drain regions with one another; the second transistors having second gates, third source/drain regions and fourth source/drain regions; the second gates gately coupling the third and fourth source/drain regions with one another; the routing structures being coupled with the second and third source/drain regions; the first source/drain regions being coupled with second sense-amplifier-circuitry; the fourth source/drain regions being coupled with a voltage source; the first and second gates being coupled with Mux-Driver-circuitry configured to selectively activate/deactivate the first and second gates; and wherein the Mux-Driver-circuitry is associated with the base and is laterally offset from the second sense-amplifier-circuitry.

20. An integrated assembly, comprising:

a memory array over a base;

vertically-extending digit lines associated with the memory array;

sense amplifiers under the memory array and coupled with the digit lines;

routing structures coupled to each of the digit lines and extending to Mux components; the Mux components being in one-to-one correspondence with the digit lines; each of the Mux components comprising a first transistor and a second transistor; the first transistors having first gates, first source/drain regions and second source/drain regions; the first gates gately coupling the first and second source/drain regions with one another; the second transistors having second gates, third source/drain regions and fourth source/drain regions; the second gates gately coupling the third and fourth source/drain regions with one another; the routing structures being coupled with the second and third source/drain regions; the first source/drain regions being coupled with second sense-amplifier-circuitry; the fourth source/drain regions being coupled with a voltage source; the first and second gates being coupled with Mux-Driver-circuitry configured to selectively activate/deactivate the first and second gates; and wherein the first transistors have higher threshold voltages than the second transistors.

21. An integrated assembly, comprising:

a memory array over a base;

vertically-extending digit lines associated with the memory array;

sense amplifiers under the memory array and coupled with the digit lines, wherein circuitry of at least one sense amplifier is configured to be utilized to provide for PRECHARGE operations and signal boosting operations;

routing structures coupled to each of the digit lines and extending to Mux components; the Mux components being in one-to-one correspondence with the digit lines; each of the Mux components comprising a first transistor and a second transistor; the first transistors having first gates, first source/drain regions and second source/drain regions; the first gates gately coupling the first and second source/drain regions with one another; the second transistors having second gates, third source/drain regions and fourth source/drain regions; the second gates gately coupling the third and

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fourth source/drain regions with one another; the routing structures being coupled with the second and third source/drain regions; the first source/drain regions being coupled with second sense-amplifier-circuitry; the fourth source/drain regions being coupled with a voltage source; the first and second gates being coupled with Mux-Driver-circuitry configured to selectively activate/deactivate the first and second gates; and wherein the first transistors have substantially the same threshold voltage as the second transistors.

22. An integrated assembly, comprising:

a memory array over a base;

vertically-extending digit lines associated with the memory array;

sense amplifiers under the memory array and coupled with the digit lines;

routing structures coupled to each of the digit lines and extending to Mux components; the Mux components being in one-to-one correspondence with the digit lines; each of the Mux components comprising a first transistor and a second transistor; the first transistors having first gates, first source/drain regions and second source/drain regions; the first gates gately coupling the first and second source/drain regions with one another; the second transistors having second gates, third source/drain regions and fourth source/drain regions; the second gates gately coupling the third and fourth source/drain regions with one another; the routing structures being coupled with the second and third source/drain regions; the first source/drain regions being coupled with second sense-amplifier-circuitry; the fourth source/drain regions being coupled with a voltage source; the first and second gates being coupled with Mux-Driver-circuitry configured to selectively activate/deactivate the first and second gates; and

wherein:

the sense amplifiers are first sense amplifiers;

the second sense-amplifier-circuitry comprises second sense amplifiers;

the first sense amplifiers are in configurations having no more 4 transistors; and

the second sense amplifiers are in configurations having at least 8 transistors.

23. The integrated assembly of claim 22 wherein the second sense amplifiers are in configurations having at least 12 transistors.

24. An integrated assembly, comprising:

a memory array over a base;

vertically-extending digit lines associated with the memory array;

sense amplifiers under the memory array and coupled with the digit lines;

routing structures coupled to each of the digit lines and extending to Mux components; the Mux components being in one-to-one correspondence with the digit lines; each of the Mux components comprising a first transistor and a second transistor; the first transistors having first gates, first source/drain regions and second source/drain regions; the first gates gately coupling the first and second source/drain regions with one another; the second transistors having second gates, third source/drain regions and fourth source/drain regions; the second gates gately coupling the third and fourth source/drain regions with one another; the routing structures being coupled with the second and third source/drain regions; the first source/drain regions being coupled with second sense-amplifier-circuitry;

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the fourth source/drain regions being coupled with a voltage source; the first and second gates being coupled with Mux-Driver-circuitry configured to selectively activate/deactivate the first and second gates; and
 wherein:
 the first sense-amplifier-circuitry comprises a first threshold voltage associated therewith;
 the second sense-amplifier-circuitry comprises a second threshold voltage associated therewith; and
 the second threshold voltage is greater than the first threshold voltage.
 25. An integrated assembly, comprising:
 a memory array over a base;
 vertically-extending digit lines associated with the memory array;
 sense amplifiers under the memory array and coupled with the digit lines;
 routing structures coupled to each of the digit lines and extending to Mux components; the Mux components being in one-to-one correspondence with the digit lines; each of the Mux components comprising a first transistor and a second transistor; the first transistors having first gates, first source/drain regions and second source/drain regions; the first gates gately coupling the first and second source/drain regions with one another; the second transistors having second gates, third source/drain regions and fourth source/drain regions; the second gates gately coupling the third and fourth source/drain regions with one another; the routing structures being coupled with the second and third source/drain regions; the first source/drain regions being coupled with second sense-amplifier-circuitry; the fourth source/drain regions being coupled with a voltage source; the first and second gates being coupled with Mux-Driver-circuitry configured to selectively activate/deactivate the first and second gates; and
 wherein the sense amplifiers are local sense amplifiers, wherein the second sense-amplifier-circuitry comprises global sense amplifiers, and wherein at least 10 of the local sense amplifiers are associated with each of the global sense amplifiers.
 26. An integrated assembly, comprising:
 a memory array over a base;
 vertically-extending digit lines associated with the memory array;
 sense amplifiers under the memory array and coupled with the digit lines;
 routing structures coupled to each of the digit lines and extending to Mux components; the Mux components being in one-to-one correspondence with the digit lines; each of the Mux components comprising a first tran-

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sistor and a second transistor; the first transistors having first gates, first source/drain regions and second source/drain regions; the first gates gately coupling the first and second source/drain regions with one another; the second transistors having second gates, third source/drain regions and fourth source/drain regions; the second gates gately coupling the third and fourth source/drain regions with one another; the routing structures being coupled with the second and third source/drain regions; the first source/drain regions being coupled with second sense-amplifier-circuitry; the fourth source/drain regions being coupled with a voltage source; the first and second gates being coupled with Mux-Driver-circuitry configured to selectively activate/deactivate the first and second gates; and
 wherein the sense amplifiers are local sense amplifiers, wherein the second sense-amplifier-circuitry comprises global sense amplifiers, and wherein at least 100 of the local sense amplifiers are associated with each of the global sense amplifiers.
 27. An integrated assembly, comprising:
 a memory array over a base;
 vertically-extending digit lines associated with the memory array;
 sense amplifiers under the memory array and coupled with the digit lines;
 routing structures coupled to each of the digit lines and extending to Mux components; the Mux components being in one-to-one correspondence with the digit lines; each of the Mux components comprising a first transistor and a second transistor; the first transistors having first gates, first source/drain regions and second source/drain regions; the first gates gately coupling the first and second source/drain regions with one another; the second transistors having second gates, third source/drain regions and fourth source/drain regions; the second gates gately coupling the third and fourth source/drain regions with one another; the routing structures being coupled with the second and third source/drain regions; the first source/drain regions being coupled with second sense-amplifier-circuitry; the fourth source/drain regions being coupled with a voltage source; the first and second gates being coupled with Mux-Driver-circuitry configured to selectively activate/deactivate the first and second gates; and
 wherein the sense amplifiers are local sense amplifiers, wherein the second sense-amplifier-circuitry comprises global sense amplifiers, and wherein at least 500 of the local sense amplifiers are associated with each of the global sense amplifiers.

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